Notice of References Cited Application/Control No. 09/043,574 Applicant(s)/Patent Under Reexamination HALBLANDER, STEFAN J. Examiner Hani Kazimi 3691 Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-			
	В	US-			
	С	US-			
	D	US-			
	Е	US-			
	æ	US-			
	G	US-			
	Ι	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	DE 0644470 A2	03-1995		Kondo, Hiroshi	
	0					
	Р					
	α					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Pascal et al. "A methodology to design a Reactive Production Management System", October 17, 1993 IEEE Systems, Man and Cybernetics Conference, pages 536-541.
	V	
	w	
	×	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.